



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Rico Cheng

Group Art Unit: 3723

Serial No.: 10/045,781

Examiner: Ojini, Eziemara Anthony

Filed: Jan. 12, 2002

In Response to Office Action

Dated: Sept. 10, 2003

For: Dual Wafer-Loss Sensor and Water Resistant Sensor Holder

Attorney Docket No.: 67,200-604

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450

Date: Oct. 8, 2003

Kathy Dixon

RESPONSE TO OFFICE ACTION

RECEIVED

OCT 15 2003

Commissioner for Patents
Alexandria, VA 22313-1450

TECHNOLOGY CENTER R3700

Dear Sir:

In response to an Office Action mailed Sept. 10, 2003 of a restriction requirement imposed by the Examiner, the Applicants hereby elect with traverse the prosecution of Group I, apparatus claims (claims 1-17). Claims 18-20 are hereby cancelled and withdrawn from further consideration by the Examiner.

Respectfully submitted,

Tung & Associates

Randy W. Tung

Reg. No. 31,311

Telephone: (248) 540-4040